

## Electronic Patent Application Fee Transmittal

<b>Application Number:</b>	10527642
<b>Filing Date:</b>	14-Mar-2005
<b>Title of Invention:</b>	METHOD FOR FORMING INSULATING FILM ON SUBSTRATE, METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE AND SUBSTRATE-PROCESSING APPARATUS
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<b>Filer:</b>	Marvin Jay Spivak/Slobodanka Alic
<b>Attorney Docket Number:</b>	267410US26PCT
Filed as Large Entity	

### U.S. National Stage under 35 USC 371 Filing Fees

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Basic Filing:</b>				
<b>Pages:</b>				
<b>Claims:</b>				
<b>Miscellaneous-Filing:</b>				
<b>Petition:</b>				
<b>Patent-Appeals-and-Interference:</b>				
<b>Post-Allowance-and-Post-Issuance:</b>				
Utility Appt Issue fee	1501	1	1440	1440
Publ. Fee- early, voluntary, or normal	1504	1	300	300

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:				
Miscellaneous:				
Total in USD (\$)				1740